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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Naoyuki KOBAYASHI et al.

Group Art Unit: 2882

Application No.: 10/588,297,

Examiner: M. ASFAW

Filed: August 2, 2006

Docket No.: 128977

For: EXPOSURE APPARATUS, EXPOSURE METHOD, AND METHOD FOR PRODUCING DEVICE

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the October 26, 2010 Office Action, the shortened statutory period for reply being extended by the attached Petition for Extension of Time, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.